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Assistant Commissioner for Patents
Washington, D.C. 20231

PATENT
Attorney Docket No.: 16301-021300US
Client Reference No.: AM2119/PCT

On July 10, 2000

TOWNSEND and TOWNSEND and CREW LLP

By: *Andrew J. H.*

#15
7/18/00
MW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Karl Littau et al.

Application No.: 08/893,917

Filed: July 11, 1997

For: REMOTE PLASMA CLEANING
SOURCE HAVING REDUCED
REACTIVITY WITH A SUBSTRATE
PROCESSING CHAMBER

Examiner: Rudy Zervigon

Art Unit: 1763

PETITION TO EXTEND TIME

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Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant petitions the Assistant Commissioner of Patents to extend the time for response to the Office Action dated March 10, 2000 for 1 month, from June 10, 2000 to July 10, 2000. An appropriate response in the form of a Response to Advisory Action is enclosed herewith.

Please charge the fee of \$110.00 to the undersigned's Deposit Account No. 20-1430. Please charge any additional fees or credit overpayment to the above deposit account. This petition is submitted in triplicate.

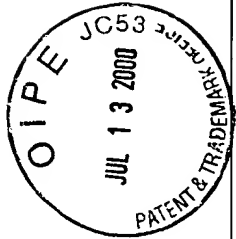
Respectfully submitted,

Chun-Pok Leung

Chun-Pok Leung
Reg. No. 41,405

TOWNSEND and TOWNSEND and CREW LLP
Two Embarcadero Center, 8th Floor
San Francisco, California 94111-3834
Tel: 650-326-2400
Fax: 650-326-2422
RL:asb

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